TED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Katsumi Sameshima

Examiner:

Wai-Sing Louie

Serial No.:

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Group Art Unit:

2814

Filed: November 30, 1999

Docket:

362-39 RCE

For:

FERROELECTRIC MEMORY AND METHOD FOR MANUFACTURING SAME

Confirmation No.: 9727

Commissioner for Patents Washington, D.C. 20231

Dated: February 21, 2003

I hereby certify this correspondence is being deposited with the United States Postal Service as first class mail, postpaid in an envelope, addressed to: Commissioner for Patents, Washington, D.C. 20231 on

February 21, 2003

Signature: Margnerte Marguerite Franco

REPLY TO FINAL OFFICE ACTION

Sir:

In response to the Office Action mailed October 21, 2002, please amend the aboveidentified application as follows:

IN THE CLAIMS:

Please amend Claims 2 and 3 by rewriting the same as follows:

2. (Thrice Amended) A ferroelectric memory, comprising:

an insulation film having a hollow at a top surface; and

a laminated body obtained by laminating a plurality of layers on said top surface and etching a region of said plurality of layers corresponding to a region other than said hollow, wherein said laminated body includes a lower electrode layer, a ferroelectric layer formed on said lower electrode layer and an upper electrode layer formed on said ferroelectric layer; and the memory further comprising another film embedded from said top surface of said insulation film in a position of a predetermined depth, exposed only at a bottom of said

. ... in 1911.1